## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

icant:

Yong-Jun Hu

LOW ANGLE, LOW ENERGY PHYSICAL VAPOR DEPOSITION OF ALLOYS

Docket No.:

303.098US4

Filed:

April 5, 2001

Examiner:

Joseph H Nguyen

Serial No.: 09/826661

Due Date: March 11, 2004

Group Art Unit: 2815

MS Non-Fee Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

A return postcard.

An Amendment and Response (8 Pages).

Please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

Customer Number 21186

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS Non-Fee Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 11th day of March, 2004.

Name

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

(GENERAL)

Signature

<u>S/N 09/826,661</u> <u>PATENT</u>

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**ALLOYS** 

## **AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

This paper responds to the Office Action mailed on <u>December 11, 2003</u>. Please amend the above-identified patent application as follows.